

Docket No.: 1514.1032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Ji Yong PARK et al.

Application No. 10/690,507

Group Art Unit: 1722

Confirmation No. 6043

Filed: October 23, 2003

Examiner: Matthew J. Song

For: METHOD FOR MANUFACTURING POLYCRYSTALLINE SILICON THIN FILM AND
THIN FILM TRANSISTOR FABRICATED USING POLYCRYSTALLINE SILICON THIN
FILM MANUFACTURED BY THE MANUFACTURING METHOD

AMENDMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

September 13, 2007

Sir:

This is in response to the Office Action mailed June 14, 2007, and having a period for response set to expire on September 14, 2007.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.